

# Measuring HMM similarity with the Bayes probability of error

An application to on-line handwritten character recognition

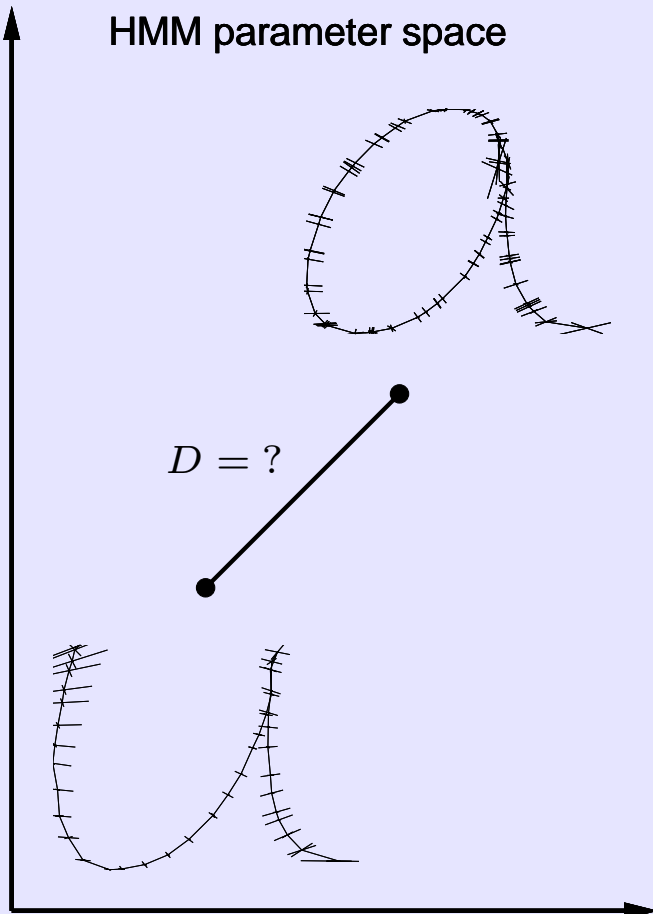
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## Abstract

- Introduction
- Sequence Classifiers
  - Dynamic Time Warping (DTW)
  - Statistical DTW/HMM
- Proposed HMM Similarity Measure
- Experiments with on-line handwritten characters

# Introduction

## Problem



## Context

On-line handwritten character recognition

## Why do we need HMM distance?

- detection of “close” competing HMMs
- interpretation of misclassifications
- monitoring iterative training process
- HMM clustering

## Approach

classification-oriented

# Dynamic Time Warping (DTW)

Alignment distance:

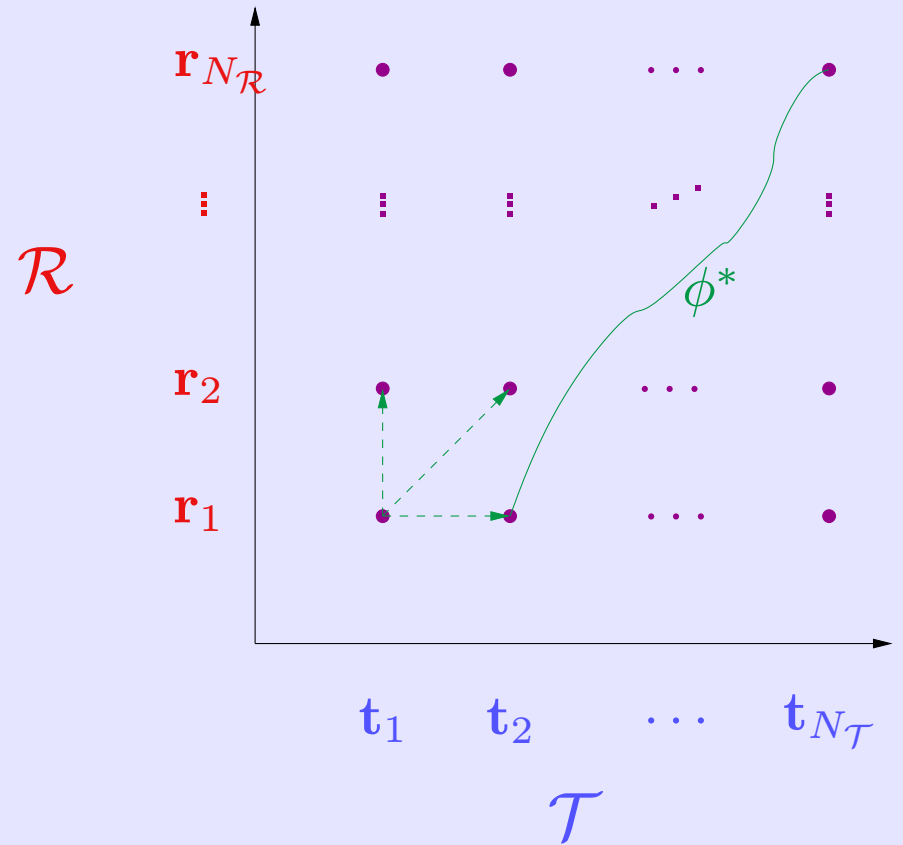
$$D_{\phi}(\mathcal{T}, \mathcal{R}) = \frac{1}{N} \sum_{i=1}^N d(\mathbf{t}_{\phi_{\mathcal{T}}(i)}, \mathbf{r}_{\phi_{\mathcal{R}}(i)})$$

Viterbi distance:

$$D(\mathcal{T}, \mathcal{R}) = D_{\phi^*}(\mathcal{T}, \mathcal{R}) = \min_{\phi} \{D_{\phi}(\mathcal{T}, \mathcal{R})\}$$

Local distance: Euclidean distance

$$d(\mathbf{t}_i, \mathbf{r}_j) = \|\mathbf{t}_i - \mathbf{r}_j\|$$



# Statistical DTW (SDTW), HMM

Alignment distance:

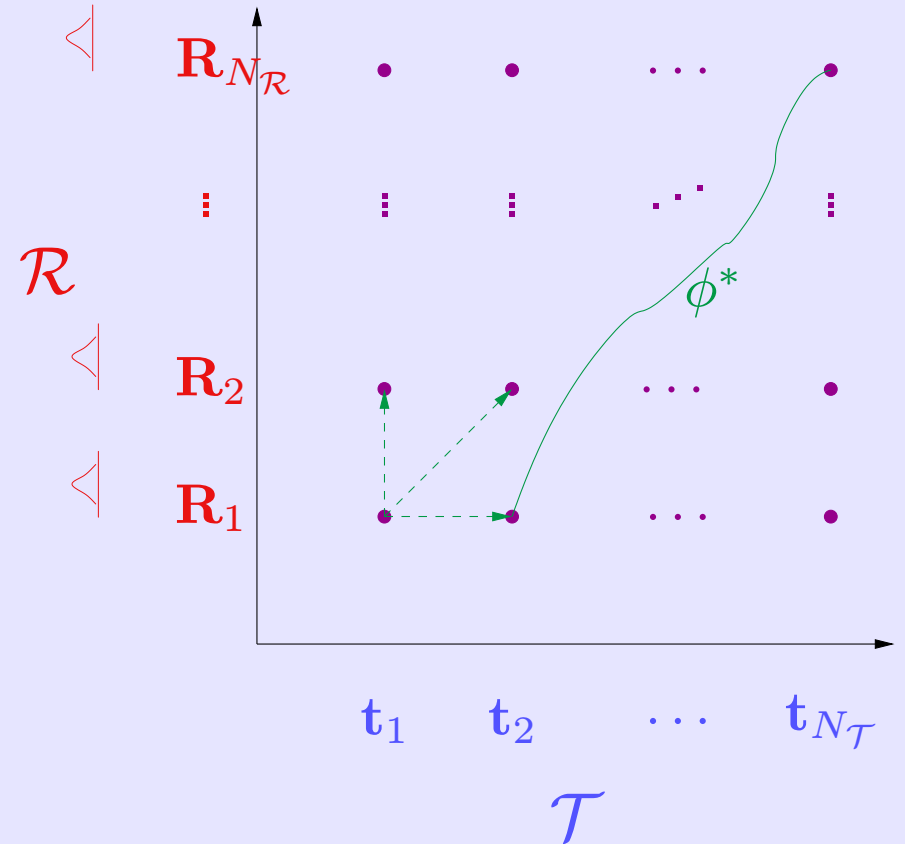
$$D_{\phi}(\mathcal{T}, \mathcal{R}) = \frac{1}{N} \sum_{i=1}^N d(\mathbf{t}_{\phi_{\mathcal{T}(i)}}, \mathbf{R}_{\phi_{\mathcal{R}(i)}})$$

Viterbi distance:

$$D(\mathcal{T}, \mathcal{R}) = D_{\phi^*}(\mathcal{T}, \mathcal{R}) = \min_{\phi} \{D_{\phi}(\mathcal{T}, \mathcal{R})\}$$

Local distance:  $-\log$  a-posteriori probability

$$d(\mathbf{t}_i, \mathbf{R}_j) = -\log P(\mathbf{t}_i | \mathbf{R}_j)$$



# SDTW/HMM Similarities

Alignment distance:

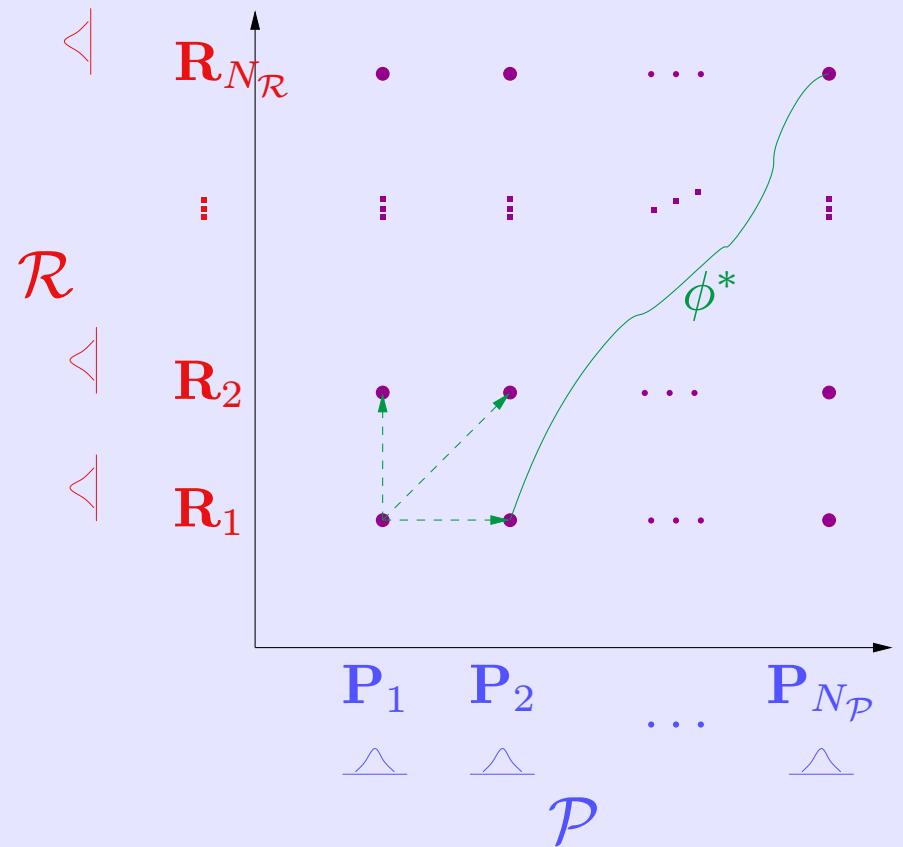
$$D_{\phi}(\mathcal{P}, \mathcal{R}) = \frac{1}{N} \sum_{i=1}^N d(\mathbf{P}_{\phi_{\mathcal{T}(i)}}, \mathbf{R}_{\phi_{\mathcal{R}(i)}})$$

Viterbi distance:

$$D(\mathcal{P}, \mathcal{R}) = D_{\phi^*}(\mathcal{P}, \mathcal{R}) = \min_{\phi} \{D_{\phi}(\mathcal{P}, \mathcal{R})\}$$

Local distance:

$$d(\mathbf{P}_i, \mathbf{R}_j) = ?$$

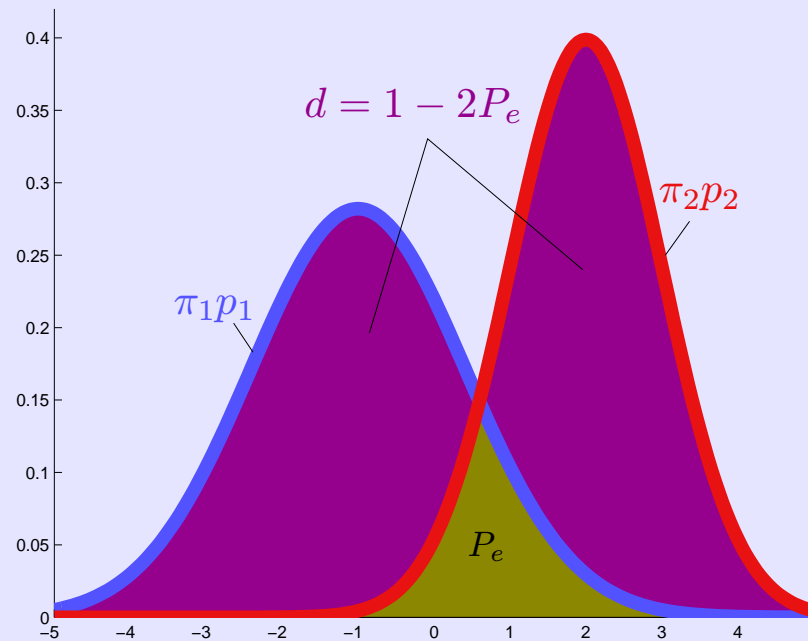


# Bayes Error

Overlap of two pdfs  $p_1$  and  $p_2$  with prior probabilities  $\pi_1$  and  $\pi_1$ .

$$P_e(p_1(\mathbf{x}), p_2(\mathbf{x})) = \int_{\mathbf{x}} \min\{\pi_1 p_1(\mathbf{x}), \pi_2 p_2(\mathbf{x})\} d\mathbf{x}$$

$$d(p_1(\mathbf{x}), p_2(\mathbf{x})) = 1 - 2P_e(p_1(\mathbf{x}), p_2(\mathbf{x}))$$



# SDTW/HMM Similarities

Alignment distance:

$$D_{\phi}(\mathcal{P}, \mathcal{R}) = \frac{1}{N} \sum_{i=1}^N d(\mathbf{P}_{\phi_{\mathcal{T}(i)}}, \mathbf{R}_{\phi_{\mathcal{R}(i)}})$$

Viterbi distance:

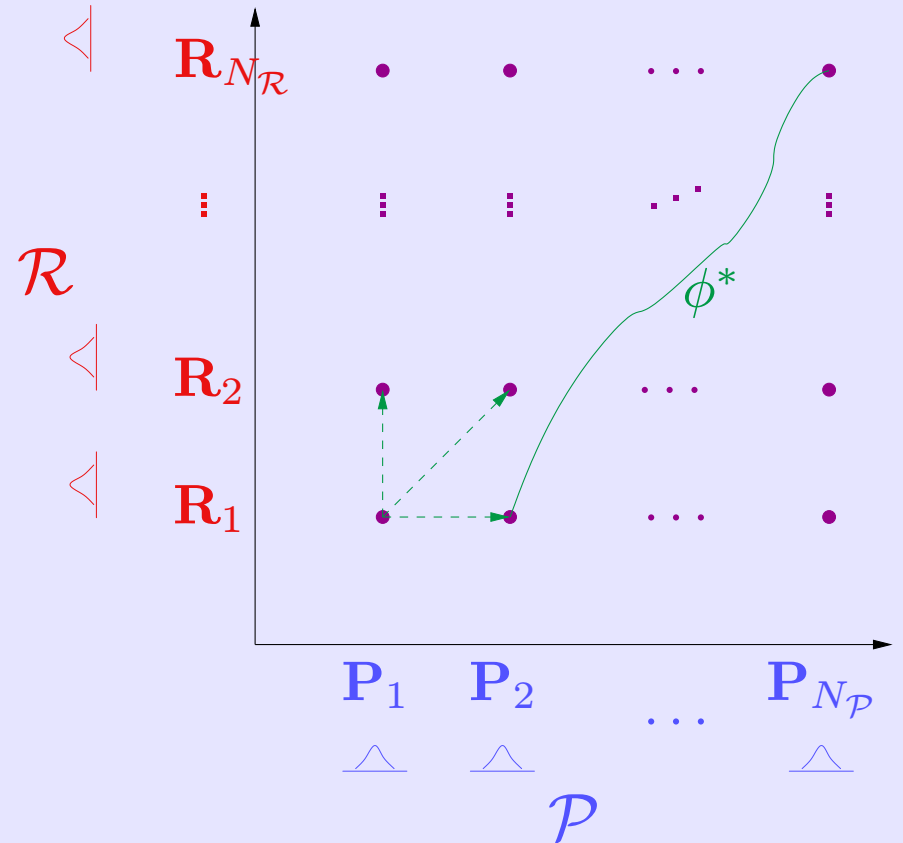
$$D(\mathcal{P}, \mathcal{R}) = D_{\phi^*}(\mathcal{P}, \mathcal{R}) = \min_{\phi} \{D_{\phi}(\mathcal{P}, \mathcal{R})\}$$

Local distance:

$$d(\mathbf{P}_i, \mathbf{R}_j) = 1 - 2P_e(\mathcal{N}(\mathbf{P}_i, \mathbf{x}), \mathcal{N}(\mathbf{R}_j, \mathbf{x}))$$

Backtransformation:

$$P_e^*(\mathcal{P}, \mathcal{R}) = \frac{1}{2} (1 - D(\mathcal{P}, \mathcal{R}))$$



# Description of experiments

UNIPEN:  
12000 isolated  
on-line lower  
case  
characters

a ... z

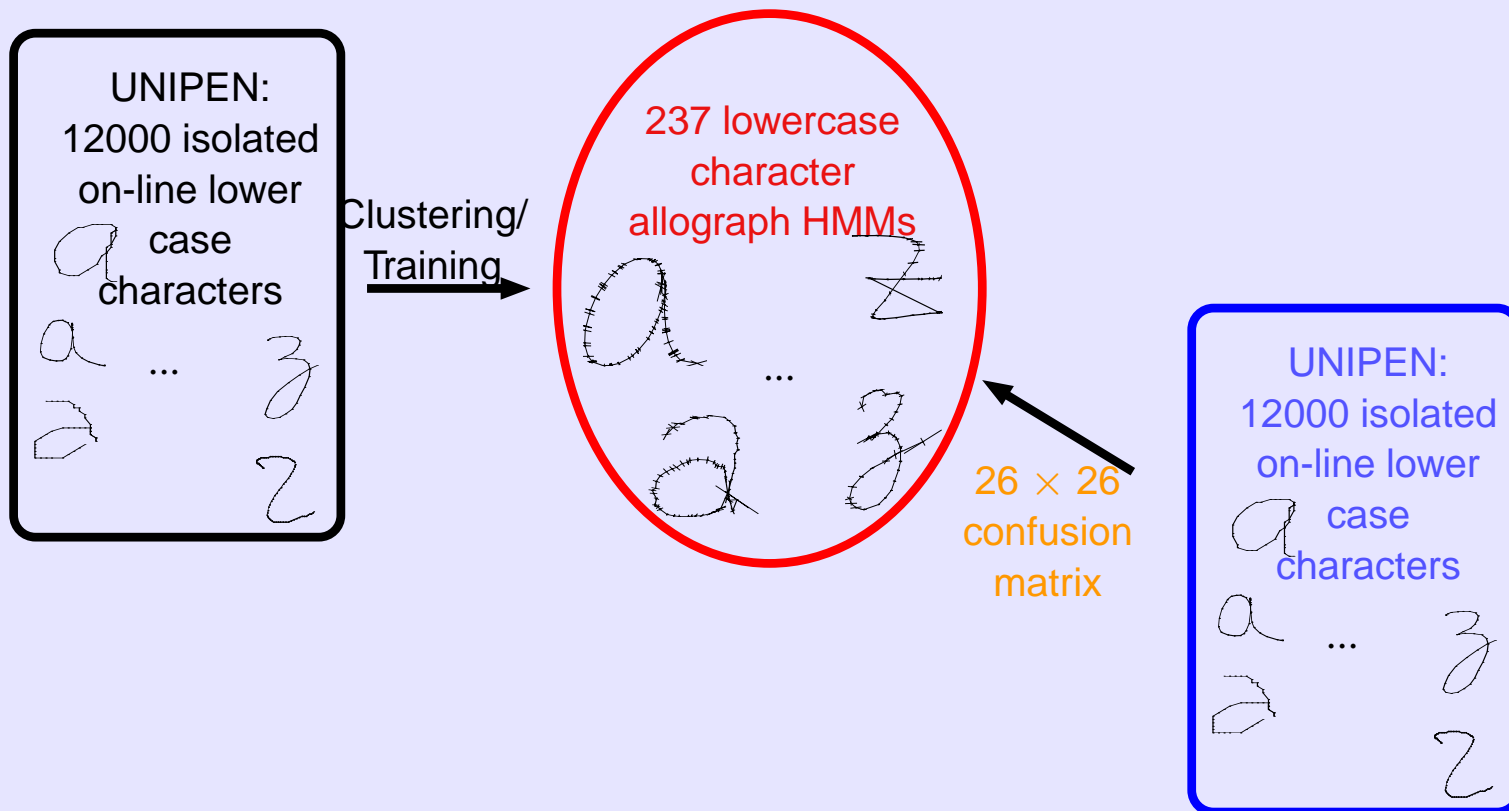
a ... z



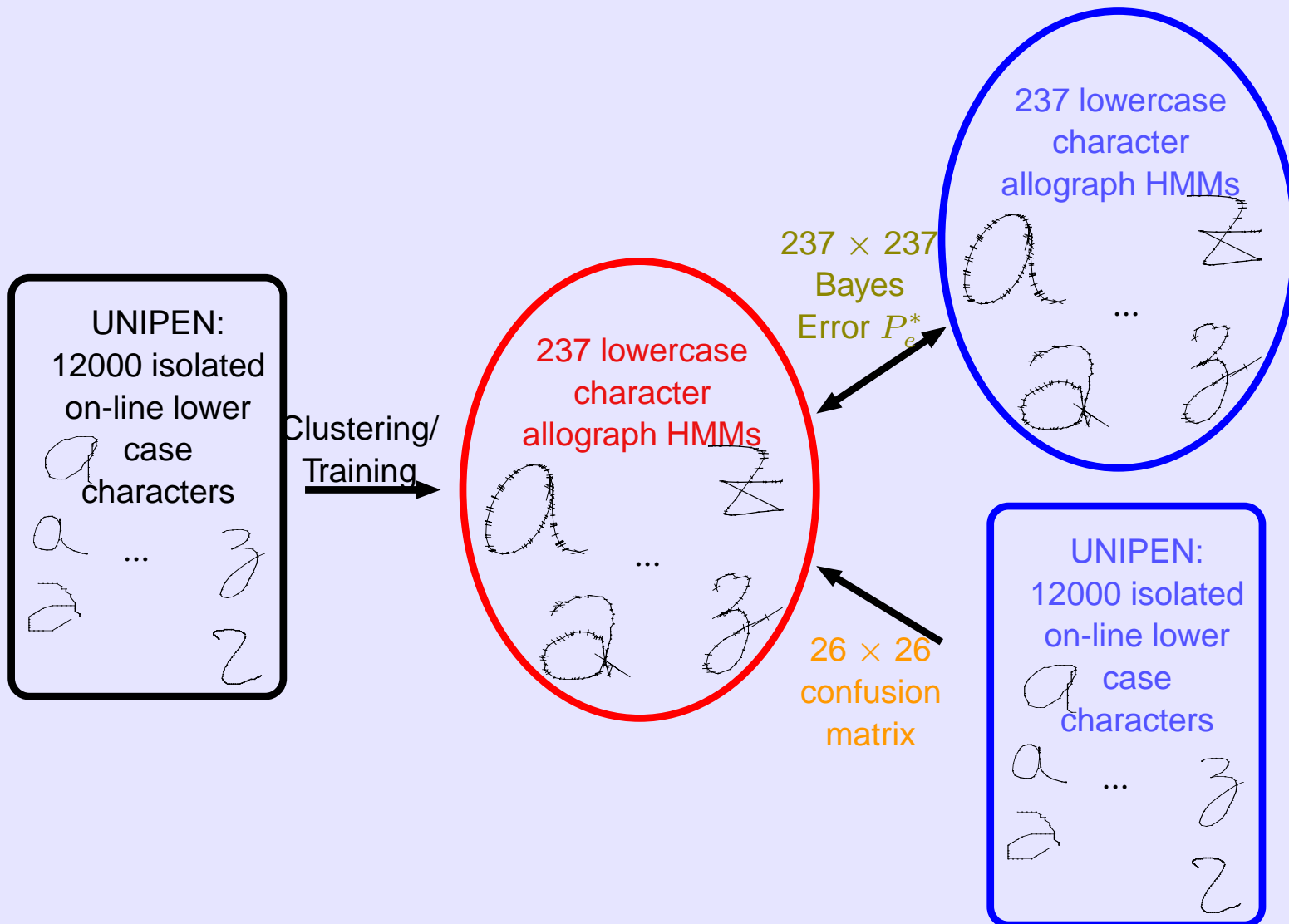
# Description of experiments



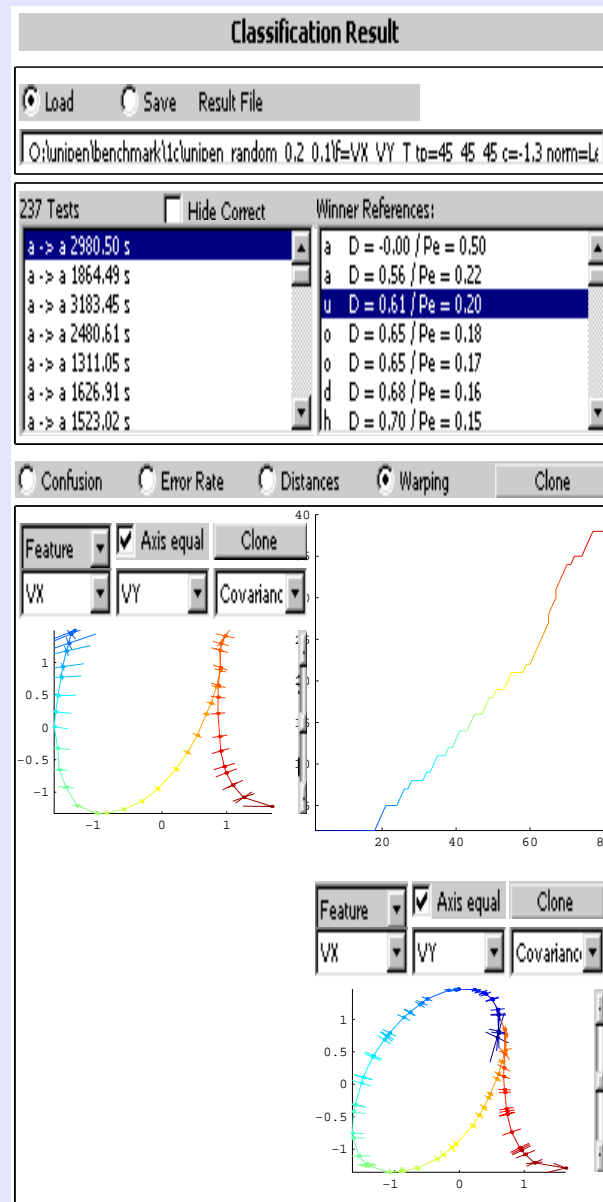
# Description of experiments



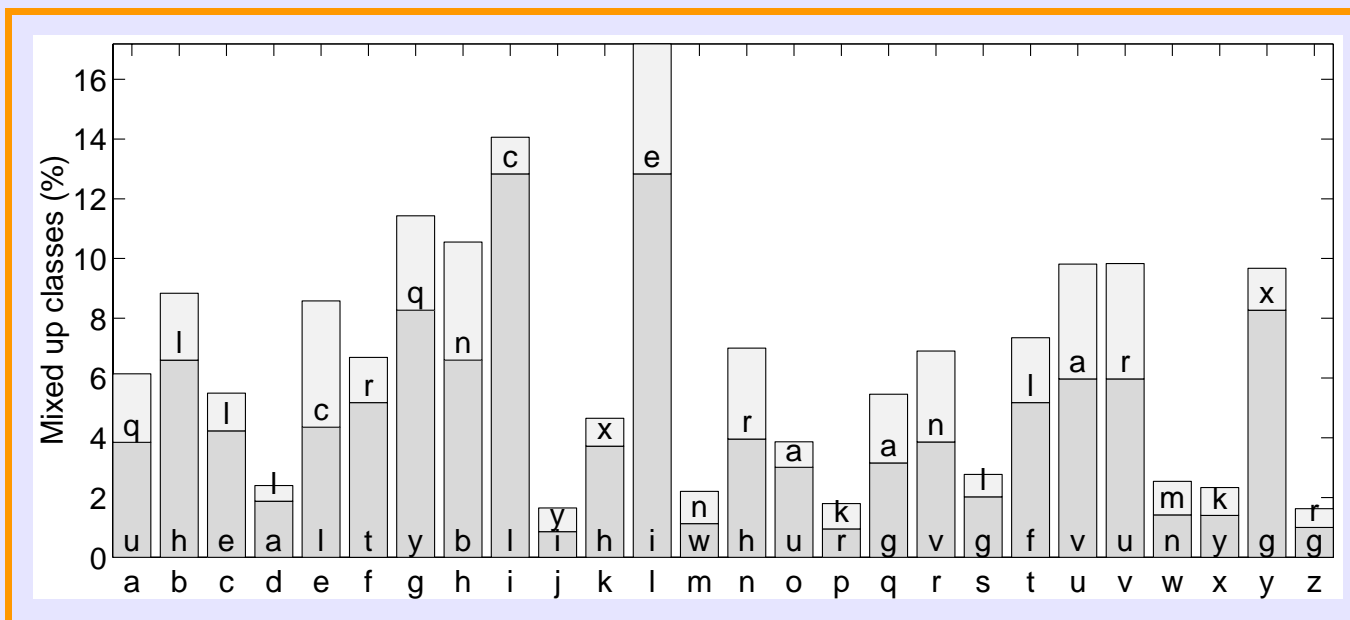
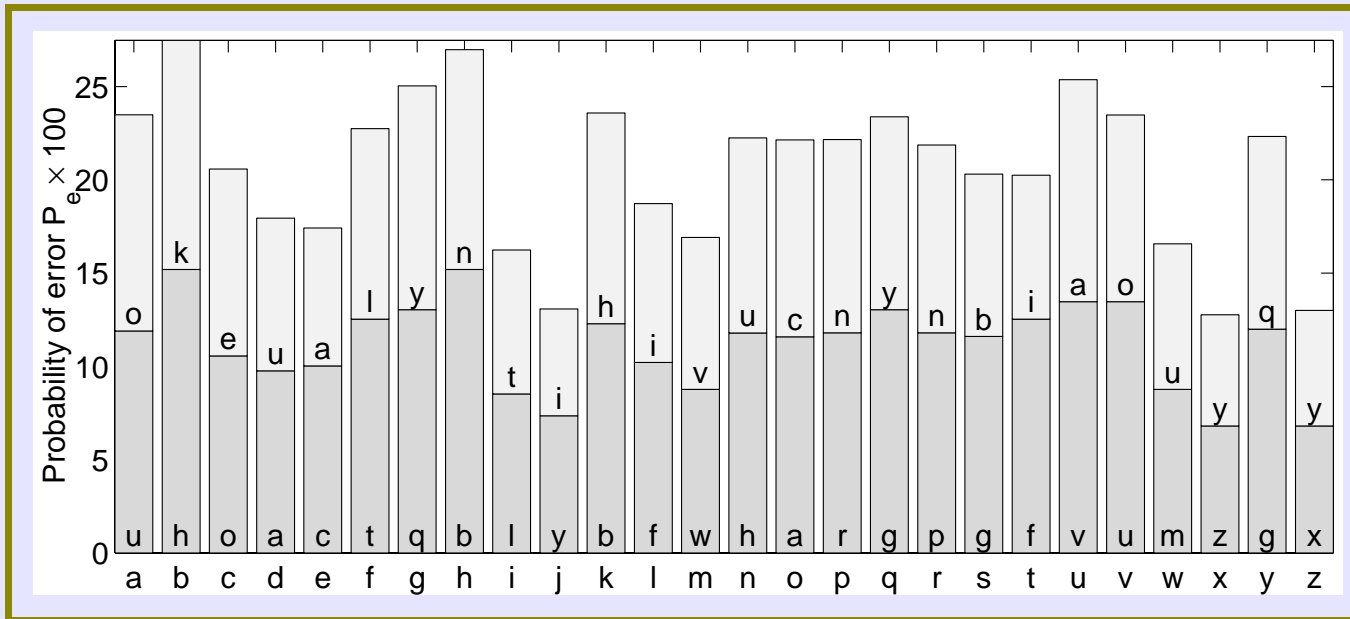
# Description of experiments



# Examples of Bayes error



# Comparing Bayes Error and Classification Confusions



# Conclusion

- Several Applications for distance measure
- Introduced HMM Similarity Measure
  - DTW / HMM classification as starting point
  - flexible in definition of local distance (Bayes error,  $\chi^2$ , Kullback-Leibler or Jensen-Shannon.)
  - not limited to handwriting recognition
- Experiments show
  - correspondence of similarity measure with visually assessed similarity
  - qualitative correlation of most similar and mostly confused classes

# Future Work

- Discriminative training / hybrid classifiers for *similar* HMMs
- distance measure as stop criterion for iterative HMM training
- modeling transition probabilities
- Gaussian mixture models

# Comparing Error Probability and Misclassifications

$P_e^* (\mathcal{R}^{l'k'}, \mathcal{R}^{lk})$ : Error probability of prototype  $l'k'$  and  $lk$

$C_{l',l}$ : Number of classifications from class  $l$  into  $l'$

Prob. of error	Misclassification
$237^2 \times P_e^* (\mathcal{R}^{l'k'}, \mathcal{R}^{lk})$	$26^2 \times C_{l'l}$
↓	↓
$\tilde{P}_e^* (l', l) = \mathcal{E} \left[ P_e^* (\mathcal{R}^{l'k'}, \mathcal{R}^{lk}) \right]_{k',k}$	$C'_{l'l} = C_{l'l} / (C_{l'l} + C_{ll})$
	↓
	$\tilde{C}_{l'l} = \tilde{\pi}_{l'l} C'_{l'l} + \tilde{\pi}_{l'l'} C'_{l'l'}$



# Feature Extraction

- Data:

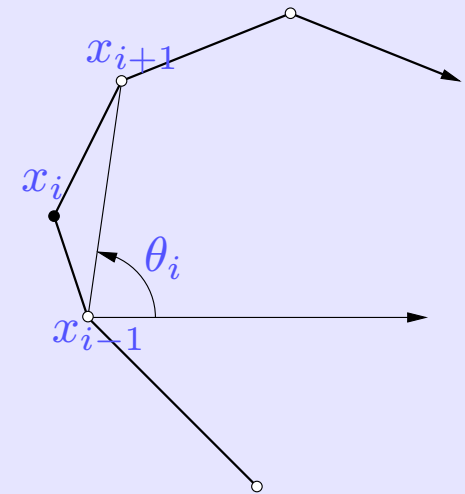
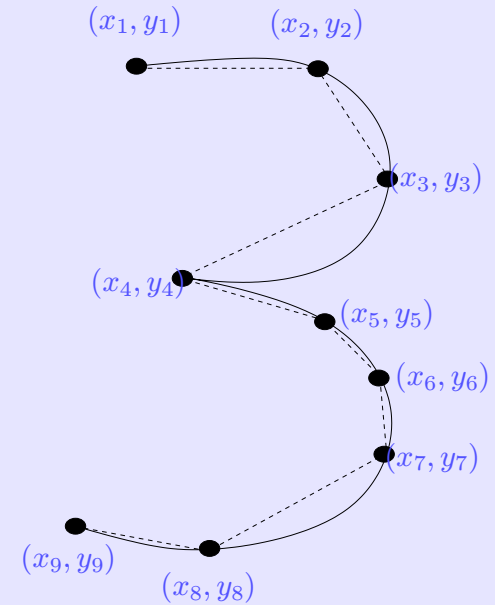
polygon  $[(x_i, y_i)]_{i=1, \dots, N_{\mathcal{T}}}$

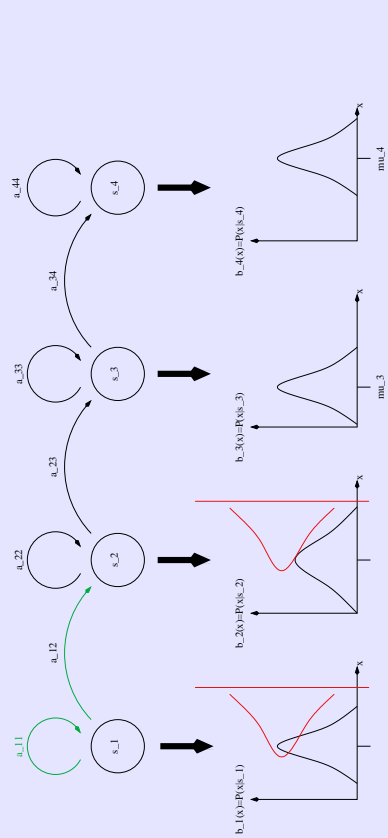
- Features:

- normalized  $x$ -coordinate  $\tilde{x}_i = \frac{x_i - \mu_x}{\sigma_x}$
- normalized  $y$ -coordinate  $\tilde{y}_i = \frac{y_i - \mu_y}{\sigma_y}$
- tangent angle  $\theta_i = \text{ang}((x_{i+1} - x_{i-1}) + j \cdot (y_{i+1} - y_{i-1}))$

feature vector  $\mathbf{t}_i = (\tilde{x}_i, \tilde{y}_i, \theta_i)^T$

writing  $\mathcal{T} = (\mathbf{t}_1, \dots, \mathbf{t}_{N_{\mathcal{T}}})$





$\mathcal{R}$

$\mathbf{R}_{N_{\mathcal{R}}}$

$\mathbf{R}_2$

$\mathbf{R}_1$

